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#10/B 1BCB 5-21-03

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

In re the application of:

John Haig MARSH et al.

Serial No.:

09/916,802

Filed:

July 27, 2001

Art Unit:

2828

Examiner:

James W. Davie

Confirmation No.:

2109

For:

IMPROVED SEMICONDUCTOR LASER

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

Name

Date of Signature

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REPLY BY APPLICANTS UNDER 37 CFR § 1.111(b)

Dear Sir:

This communication is responsive to the Examiner's Action mailed January 13, 2003.

Please amend the claims as shown on the following pages. This style of amendment follows the Official Gazette Notice of January 25, 2003, in which a single set of all of the claims, showing their present status and amendments, is presented.

05/16/2003 LWDNDIM1 00000010 09916802

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